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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/614,327	07/08/2003	Bruno Ghyselen	4717-7600	7326	
28765 7:	590 06/30/2004		EXAM	INER	
WINSTON & STRAWN			WILCZEWSKI, MARY A		
PATENT DEPARTMENT 1400 L STREET, N.W.			ART UNIT	PAPER NUMBER	
WASHINGTON, DC 20005-3502			2822		
			DATE MAIL ED. 06/20/200	DATE MAIL ED: 06/20/2004	

Please find below and/or attached an Office communication concerning this application or proceeding.

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	Application No.	Applicant(s)
Office Action Summany	10/614,327	GHYSELEN ET AL.
Office Action Summary	Examiner	Art Unit
The SEATI INC. DATE - Edition - Committee of the committe	Mary Wilcz wski	2822
Th MAILING DATE of this communication ap Period for Reply	p ars on the cover sheet with th	correspondence address
A SHORTENED STATUTORY PERIOD FOR REPL THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1. after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above is less than thirty (30) days, a rep. If NO period for reply is specified above, the maximum statutory period.  - Failure to reply within the set or extended period for reply will, by statut Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	136(a). In no event, however, may a reply be ti oly within the statutory minimum of thirty (30) da will apply and will expire SIX (6) MONTHS from the, cause the application to become ABANDONE	mely filed ys will be considered timely. the mailing date of this communication. ED (35 U.S.C. § 133).
Status		
1)⊠ Responsive to communication(s) filed on <u>08 .</u> 2a)□ This action is <b>FINAL</b> . 2b)⊠ Thi  3)□ Since this application is in condition for allowed closed in accordance with the practice under	s action is non-final. ance except for formal matters, pr	
Disposition of Claims		
4) ☐ Claim(s) <u>1-35</u> is/are pending in the application 4a) Of the above claim(s) is/are withdra 5) ☐ Claim(s) is/are allowed. 6) ☐ Claim(s) is/are rejected. 7) ☐ Claim(s) is/are objected to. 8) ☐ Claim(s) <u>1-35</u> are subject to restriction and/or	awn from consideration.	
Application Papers		
9)☐ The specification is objected to by the Examin 10)☒ The drawing(s) filed on 08 July 2003 is/are: a Applicant may not request that any objection to the Replacement drawing sheet(s) including the correct 11)☐ The oath or declaration is objected to by the E	)⊠ accepted or b)⊡ objected to e drawing(s) be held in abeyance. Se ction is required if the drawing(s) is ob	e 37 CFR 1.85(a). ojected to. See 37 CFR 1.121(d).
Priority under 35 U.S.C. § 119		
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of:  1. Certified copies of the priority document 2. Certified copies of the priority document 3. Copies of the certified copies of the priority application from the International Bureat*  * See the attached detailed Office action for a list	nts have been received.  Its have been received in Applicatority documents have been received in Rule 17.2(a)).	ion No ed in this National Stage
Attachment(s)		
Notice of References Cited (PTO-892)	4) 🔲 Interview Summary Paper No(s)/Mail D	
3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08 Paper No(s)/Mail Date		Patent Application (PTO-152)

#### **DETAILED ACTION**

## Election/Restrictions

Restriction to one of the following inventions is required under 35 U.S.C. 121:

- Claims 1-25 and 34-35, drawn to a method of preparing a semiconductor wafer, classified in class 438, subclass 455.
- II. Claims 26-33, drawn to a semiconductor wafer, classified in class 257, subclass 618+.

The inventions are distinct, each from the other because of the following reasons:

Inventions I and II are related as process of making and product made. The inventions are distinct if either or both of the following can be shown: (1) that the process as claimed can be used to make other and materially different product or (2) that the product as claimed can be made by another and materially different process (MPEP § 806.05(f)). In the instant case unpatentability of the group II invention would not necessarily imply unpatentability of the group I invention, since the semiconductor wafer of the group II invention could be made by processes materially different than those of the group I invention, for example, rather than forming the second layer on the first layer and subsequently creating a region of weakness in the matching substrate and removing the first layer from the second layer, the second layer could be formed directly on the handle wafer.

Because these inventions are distinct for the reasons given above and have acquired a separate status in the art as shown by their different classification, restriction for examination purposes as indicated is proper.

Applicant is advised that the reply to this requirement to be complete must include an election of the invention to be examined even though the requirement be traversed (37 CFR 1.143).

Applicant is reminded that upon the cancellation of claims to a non-elected invention, the inventorship must be amended in compliance with 37 CFR 1.48(b) if one or more of the currently named inventors is no longer an inventor of at least one claim remaining in the application. Any amendment of inventorship must be accompanied by a request under 37 CFR 1.48(b) and by the fee required under 37 CFR 1.17(i).

## **Priority**

Acknowledgment is made of applicant's claim for foreign priority based on an application filed in France on July 9, 2002. It is noted, however, that applicant has not filed a certified copy of the French application as required by 35 U.S.C. 119(b).

## Drawings

The drawings filed on July 8, 2003, are acceptable.

Art Unit: 2822

#### Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to M. Wilczewski whose telephone number is (571) 272-1849. The examiner can normally be reached on Monday and Thursday.

The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

M. Wilczewski Primary Examiner Tech Center 2800